



500.42265CX1

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KUMAGAI, et al.
Application No.: 10/767,053
Filed: January 30, 2004
For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
Art Unit: 2826
Examiner: F. Abraham

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 16, 2004

Sir:

In response to the Office Action dated August 16, 2004, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Specification;

Amendments to the Abstract;

Amendments to the Claims;

Remarks are included following the amendments; and

Appendix I is included following the remarks, with a new Abstract.